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U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
					YES NO

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

<i>MJP</i>		IBM Disclosure Bulletin, <u>Ion Bombardment of Polyimide for the Alignment of Liquid Crystals</u> , New York, Vol. 23, No. 4B, 9/1/91, pp. 80-82.
<i>f</i>		Japanese Abstract No. XP-002224303, 2/28/92 to Saiko Epson Corp. for JP4063323A <i>Feb 1992</i>
		U.S. Patent Application Publication No. 2002/0001057, Publication Date Jan. 3, 2002, <u>Method and Apparatus for Making a Crystal Alignment Layer</u> <i>Chaudhari</i>
		U.S. Patent Application Publication No. 2001/0025826, Publication Date Oct. 4, 2001, <u>Dense-Plasma Etching of INP-Based Materials Using Chlorine and Nitrogen</u> <i>Pierston</i>
<i>MJP</i>		U.S. Patent Application Publication No. 2001/0041380, Publication Date Nov. 15, 2001, <u>Method for Forming a Multi-Domain Alignment Layer for a Liquid Crystal Display Device</u> <i>Samanit</i>

EXAMINER

DATE CONSIDERED

* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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